

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re United States Patent Application of:)	Docket No.:	4240-104-RCE	
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Applicants:	JUNG, Hee Tae, et al.)	Conf. No.:	9621
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Application No.:	10/805,044)	Art Unit:	1639
)			
Date Filed:	March 19, 2004)	Examiner:	Christopher M. Gross
)			
Title:	METHOD FOR FABRICATING A BIOCHIP USING THE HIGH DENSITY CARBON NANOTUBE FILM OR PATTERN)	Customer No.:	23448
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CERTIFICATE OF EFS FILING

I hereby certify that this document is being filed via EFS in the United States Patent and Trademark Office on 3/27/09.
/jason r. navari /

**SECOND SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT IN
U.S. PATENT APPLICATION NO. 10/805,044**

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

Pursuant to 37 C.F.R. §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached Form PTO/SB/08a. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

Since this Information Disclosure Statement is being filed within three months of filing of a Request for Continued Examination (filed March 26, 2009), no fee is believed due.

Respectfully submitted,

/kelly k. reynolds /
Kelly K. Reynolds
Reg. No. 51,154
Attorney for Applicants

INTELLECTUAL PROPERTY/
TECHNOLOGY LAW
Phone: (919) 419-9350
Fax: (919) 419-9354
Attorney File No.: 4240-104-RCE

Enclosures:
IDS Form(s) [7 pgs]
Cited Non Patent Literature and Foreign References [30]

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